


Form PTO 1449 (Modified)		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY DOCKET NO. 296582US2PCT		SERIAL NO. 10/593,255	
LIST OF REFERENCES CITED BY APPLICANT 				APPLICANT Woosuck SHIN, et al.		GROUP 2856	
				FILING DATE September 18, 2006			
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE	
	AA						
	AB						
	AC						
	AD						
	AE						
	AE						
	AC						
	AH						
	AI						
	AJ						
	AK						
	AL						
	AM						
	AN						
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION YES NO		
/R.E./	AD	JP 2001-099801 A	04/13/01	Japan			X
	AP	JP 2929789 B2	05/21/99	Japan (with English Abstract)			X
	AD	JP 10-26594 A	01/27/98	Japan (with English Abstract)			X
	AB	JP 2000-275203 A	10/06/00	Japan (with English Abstract)			X
	AS	JP 2003-255594 A	09/10/03	Japan (with English Abstract)			X
	AT	JP 2003-317618	11/07/03	Japan			X
	AU	JP 08-278274	10/22/96	Japan			X
	AV						
OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, etc.)							
/R.E./	AW	Varadan Vijay, et al. "Microsensors, MEMS, and Smart Devices." pages 280-302					
/R.E./	AX	SMAY E., CAESARANO III J., & LEWIS J: "Colloidal Inks for Directed Assembly of 3-D Periodic Structures" Materials Science & Engineering Department, University of Illinois at Urbana-Champaign, Urbana, Illinois 61801, and Sandia National Laboratories, Albuquerque, New Mexico 87106. Langmuir 2002, 18, 5429-5437. 2002 American Chemical Society.					
/R.E./	AY	J.E. Smay, Langmuir 2002, 18, 5429					
	AZ						<input type="checkbox"/> Additional References sheet(s) attached
Examiner		/Robert Eom/			Date Considered 03/16/2009		

*Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.